

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : TBD
Applicant : Yuichiro Sasaki et al.
Filed : Herewith
Title : "METHOD OF IMPURITY INTRODUCTION, IMPURITY INTRODUCTION APPARATUS AND SEMICONDUCTOR DEVICE PRODUCED WITH USE OF THE METHOD"

Conf. No. : TBD
TC/A.U. : TBD
Examiner : TBD

Customer No. : 052054
Docket No. : 41341

Mail Stop PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT "A"

Sir:

Please amend the above-identified application, prior to examination thereof, in the following manner.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.